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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2815**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mutsumi KIMURA et al.

Group Art Unit: 2815

Application No.: 10/764,502

Examiner: N. RICHARDS

Filed: January 27, 2004 .

Docket No.: 118215

For: THIN FILM TRANSISTOR TYPE DISPLAY DEVICE, METHOD OF
MANUFACTURING THIN FILM ELEMENT, THIN FILM TRANSISTOR CIRCUIT
BOARD, ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 1, 2005 Office Action, reconsideration of the application is respectfully requested in light of the submission of the translation of the priority document of the present application.

Claims 5, 6, 10 and 11 are pending in this application.

The Office Action rejects claims 5, 6 and 10 under 35 U.S.C. §103(a) over the 1999 Article of Shimoda et al. ("Shimoda-I") in view of the 2002 Article of Shimoda et al. ("Shimoda-II") and JP 2003-297974; and rejects claim 11 under 35 U.S.C. §103(a) over Shimoda I in view of Applicants Admitted Prior Art (APA) and JP 2003-297974. These rejections are respectfully traversed.